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Attorney Docket 0553-0393

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re Application of)
)
Shunpei Yamazaki et al.)
)
Serial No.: 10/757,167)
)
Filed: January 13, 2004)
)
For: Method For Manufacturing Conductive)
Layer And Semiconductor Device)
)
Art Unit: 2822)
)
Examiner: Christy L. Novacek)

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT (B) AFTER FINAL

Sir:

In response to the Final Rejection of October 5, 2005, please enter the following amendment
in the above-identified application:

I hereby certify that this correspondence is being deposited
with the United States Postal Service as first class mail in an
envelope addressed to:
Commissioner for Patents,
P.O. Box 1450, Alexandria, VA 22313-1450 on
January 4, 2006
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Shannon Wallace
Name of applicant, assignee, or Registered Rep.
Shannon Wallace 1/4/06
Signature Date